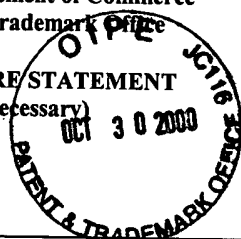


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Patent & Trademark OfficeAtty. Docket No.  
002935 USA/PDC/ICT/DBSerial No.  
09/162,103

## INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Applicant:  
Dieter WINKLER et al.Filing Date:  
September 28, 1998Group  
2881

## U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Sub-Class	Filing Date (if appropriate)
KF	5,122,663	6/16/92	Chang et al.	250	310	
KF	5,155,412	10/13/92	Chang et al.	315	14	

## FOREIGN PATENT DOCUMENTS

Document	Date	Country	Class	Sub-class	Translation Yes/No
KF HEI 11-16967	1/22/99	Japan			Yes

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

KF	Chang et al., "Electron beam technology - SEM to microcolumn," <i>Microelectronic Engineering</i> , 32 (1996) pages 113-130.

EXAMINER

DATE CONSIDERED

1-6-01

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